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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiko TSUJI et al.

Group Art Unit: 2881

Application No.: 10/585,001

Examiner: A. SMYTH

Filed: June 29, 2006

Docket No.: 128591

For: AN EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- 2. An original and English language version of the foreign Office Action are attached for the Examiner's information as Reference 1. The reference cited therein is already of record in this application.

Respectfully submitted,

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Date: May 24, 2011

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